

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuko OKADA et al. Group Art Unit: 1762

Application No.: 10/617,747 Examiner: J. LIN

Filed: July 14, 2003 Docket No.: 109100.01

For: THIN FILM FORMATION METHOD BY INK JET METHOD, INK JET

APPARATUS, PRODUCTION METHOD OF ORGANIC EL DEVICE, AND

ORGANIC EL DEVICE

AMENDMENT UNDER 37 C.F.R. §1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the January 11, 2007 Office Action, and in consideration of the Request for Continued Examination filed herewith, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.